Practitioner's Docket No. MI22-1952

**PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Reinberg, Alan R.

Application No.: 10/082,594 Filed: 02/22/02

Group No.: 2823 Examiner: H.M. Lee

For: Methods of Forming Capacitors and Resultant Capacitor Structures

Commissioner for Patents Washington, D.C. 20231

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## CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being facsimile transmitted to the Patent and Trademark Office at (703) 872-9306 on the date shown below:

Examiner Interview Summary of March 30 and 31, 2004

\_ 31,2004

Total Pages \_

Robin Saldivia

Signature

(Certification of Facsimile Transmission--page 1 of 1)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No
Filing Date February 22, 2002
Inventor Alan R. Reinberg
Assignee Micron Technology, Inc.
Group Art Unit
Examiner H.M. Lee
Attorney's Docket No MI22-1952
Title: Methods of Forming Capacitors and Resultant Capacitor Structures

## EXAMINER INTERVIEW SUMMARY OF MARCH 30 and 31, 2004

To:

Commissioner for Patents

Washington, D.C. 20231

From:

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Applicant's representative held an interview with Examiner Lee on March 30 and 31, 2004. Applicant's representative would like to thank Examiner Lee for his time and attention to this matter.

Applicant's representative and Examiner Lee held discussions regarding the deficiency of a pending Office Action, paper no. 111903. Agreement was reached.

Examiner Lee stated that he would file a new Office Action and restart the time period for responding to the new Office Action. Examiner Lee also verified this by faxing such statement to Applicant's representative on March 31, 2004.

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Applicant's representative would again like to thank Examiner Lee for his time and attention to this matter.

Respectfully submitted,

Dated: 3-3/-04

Reg. No. 40,045